

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: HIROSHI NAKAMURA ET AL.)
) Group Art Unit: 2624
Serial No.: 10/540,368)
) Examiner: Fujita, Katrina R
Filed: JUNE 23, 2005)
) Confirmation No. 2573
For: PATTERN IDENTIFICATION METHOD)
)
) AND PATTERN IDENTIFICATION)
)
) DEVICE)

Customer No.: 23413

RESPONSE TO RESTRICTION REQUIREMENT

Via EFS
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In response to the Restriction Requirement mailed May 15, 2008, Applicant submits the following response.